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SERIAL NUMBER 10/019,407	FILING OR 371(c) DATE 03/25/2002 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 520.41003 X00
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APPLICANTS

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**** CONTINUING DATA *******

This application is a 371 of PCT/JP00/04141 06/23/2000

**** FOREIGN APPLICATIONS *******

JAPAN 11/181559 06/28/1999

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no		
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after		
Verified and Acknowledged	Examiner's Signature		
	Initials		
STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
JAPAN	16	20	9

ADDRESS

20457

TITLE

Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device

FILING FEE RECEIVED 1524	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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